2012 IEEE Nuclear Science Symposium

29th October – 3rd November 2012 Anaheim, CA

Monolithic Active Pixel Silicon Detector for Electron Relativistic Heavy Ion Colliders: Status and Plans

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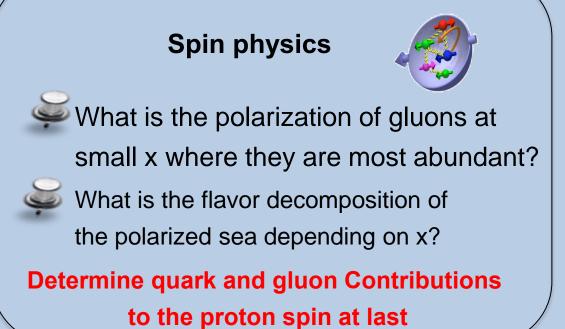
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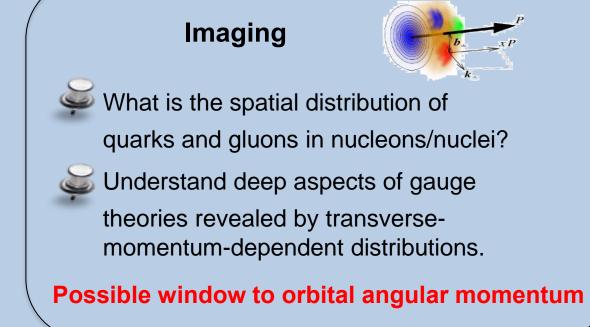
There are still many open questions regarding the nucleon spin structure and transverse-momentumand impact-parameter-dependent parton distributions in nucleons and nuclei.

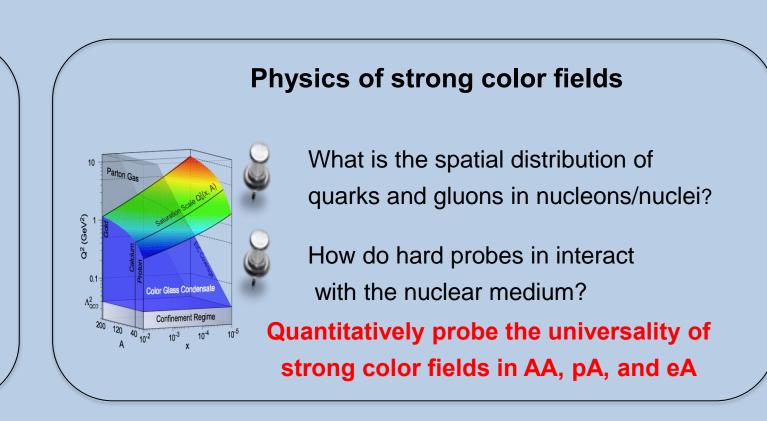
The best way to investigate nucleon and ion structure is to built a electron-ion collider (EIC). This collider can be realized at Brookhaven National Laboratory, inside the existing RHIC tunnel.

A detector for an EIC will require an excellent vertex tracking system. MAPS silicon detectors are the most promising candidates for this task.

Physics motivations of an electron-ion collider





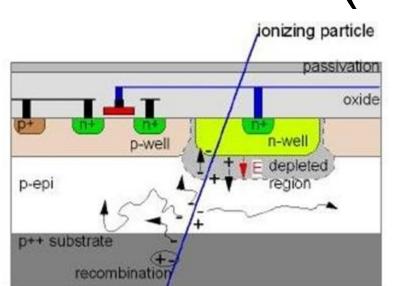


EIC at RHIC: the eRHIC project

- ✓ Polarized electrons: 5, 10, 20, (30?) GeV
- ✓ Polarized protons: 100 to 250 GeV √lons: 50 to 100 GeV per nucleon
 - - Key-points: ✓ Electron beam: novel energy recovery Linacs.
 - ✓ Proton beam: coherent electron cooling.
 - ✓ Crab Crossing Cavities to restore head-to-head bunch collisions.
- ✓ No other tunnel required: electron beam line will be added in the present RHIC tunnel.
- ✓ Up to 3 experimental locations along the ring.

Preliminary design of the eRHIC Detector 2-3T Solenoid Solenoid EM-Calorimeter **Dual Radiator RICH** Aerogel RICH / DIRC/ HR-ToF **Tracking**

Monolithic Active Pixel Silicon (MAPS) Sensor



- Sensor and Chip realized in the same CMOS process: cheap to produce and no bump bonding required.
- ✓ No HV bias: electrons collected for thermal diffusion.
- ✓ Works at room temperature: minimal cooling system required (low material budget!).
- ✓ Sensitive area only ~15 microns thick. ✓ Very high granularity.

BNL and Columbia University test stations

silicon vertex

For the eRHIC silicon vertex detector the candidate technology is a MAPS pixel of the e Mimosa family, designed at the Institut Pluridisciplinaire Ubert Curien (Strasburg).

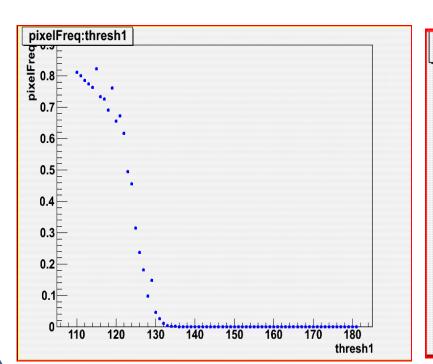
At Brookhaven National laboratory and Columbia University there are two test stations working with the Mimosa 26 prototype.

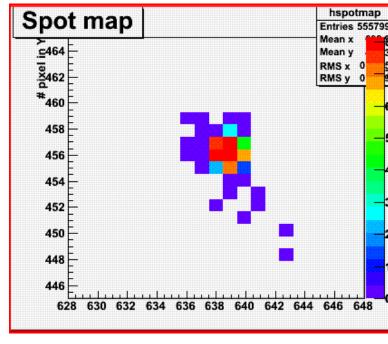
Studies for the eRHIC

Laser source studies:

Left: each point represents the fraction of times the chip registered a hit for that pixel when the laser was fired ~9000 times, as function of threshold value, in mV (horizontal axis). This curve is for a pixel hit localized 2 pixels away from the "center" of the spot.

Right: Beam laser spot i.e. space distribution of the hits when the laser was fired 9000 times.





Outlook

Vertex Tracking

MAPS implementation in the

STAR Detector upgrade

(Mimosa 28 Ultimate)

✓ Two barrel layers will be

upgrade.

added in the next incoming

The first electron-ion collider (EIC) can be easy realized in BNL using the existing RHIC tunnel. There is already a general design for the collider and the detector: the eRHIC project.

Studies are also ongoing in order to use MAPS sensors in a high-precision silicon vertex detector.

Acknowledgements

Thanks to the BNL EIC Task Force and to the BNL Collider Accelerator Department for the contributions and the useful discussions. This work is supported with the BNL LDRD program.









